High-pressure Synthesis, Structure and Novel Photochemical Reactions of 7,7,8,8-Tetramethyl-7,8-disilabicyclo[2.2.2]octa-2,5-diene

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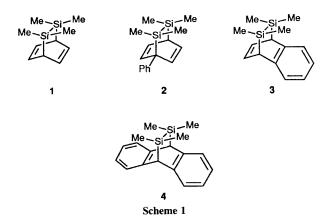
7,7,8,8-Tetramethyl-7,8-disilabicyclo[2.2.2]octa-2,5-diene **1**, prepared by the high-pressure reaction (10000 bar) of 1,1,2,2-tetramethyl-1,2-disilacyclohexa-3,5-diene and phenyl vinyl sulphoxide followed by elimination of benzenesulphenic acid, gave tetramethyldisilene (Me₂Si=SiMe₂) upon photolysis which underwent a photochemical [2 + 4] reaction with benzene at 10 K in an argon matrix to regenerate the precursor.

7,8-Disilabicyclo[2.2.2]octa-2,5-diene derivatives¹ such as **2**, **3** and **4** generate highly reactive tetramethyldisilene by either thermolysis² or photolysis.³ These compounds thus behave as masked disilenes. Anionic polymerization of masked disilenes **2** to high-molecular weight polysilylenes has also been reported recently.⁴

The parent compound **1** is of special interest in view of its highly symmetrical and simple structure, although the synthe-

sis is not straightforward. We report herein the first successful preparation of 7,7,8,8-tetramethyl-7,8-disilabicyclo-[2.2.2]octa-2,5-diene 1. Its molecular structure was determined by X-ray crystallography and unique photochemical reactions are reported as well.

The synthetic strategy for the preparation of 1 is based on the Diels-Alder reactions of 1,1,2,2-tetramethyl-1,2-disilacyclohexa-3,5-diene 5^5 with alkynes. After several unsuccess-



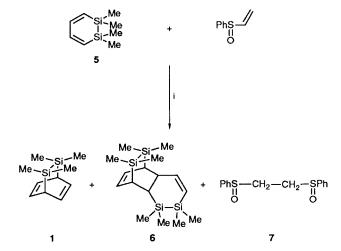
ful attempts, we have found that the Diels–Alder reaction of **5** with phenyl vinyl sulphoxide followed by elimination of benzenesulphenic acid under ultra high pressure gave **1**. Thus, a diethyl ether solution of **5** (0.30 g, 1.79 mmol) and phenyl vinyl sulphoxide (0.59 g, 3.88 mmol) was heated at 100 °C for 12 h under a pressure of 10000 bar. Silica gel chromatography with hexane under argon followed by preparative gas chromatography afforded pure **1** (40 mg, 12%).† The dimer **6**‡ and 1,2-bis(phenylsulphinyl)ethane **7** were also formed. Application of ultra high pressure is essential in this reaction, since **1** is not formed under normal conditions.

Since no crystallographic structures have been reported for 7,8-disilabicyclo[2.2.2]octa-2,5-diene derivatives, the structure of **1** was determined by X-ray crystallography.§ Several interesting features of the structure can be pointed out. As shown in Fig. 1, the four alkenic carbons [C(2), C(3), C(5) and C(6)] are coplanar, while the bridged carbons [C(1) and C(4)] are located above the C(2)–C(3)–C(5)–C(6) plane. The dihedral angles between C(1)–C(2)–C(6) [or C(3)–C(4)–C(5)] and C(2)–C(3)–C(5)–C(6) planes are 33.8 ° (av.). The Si–Si bond (2.363 Å), parallel to the C(2)–C(3)–C(5)–C(6) plane, is slightly elongated. As a result, **1** was readily autoxidized to give mainly 2,2,4,4-tetramethyl-3-oxa-2,4-disilabicyclo-[3.2.2]nona-6,8-diene. The bridging Si–C bonds (av. 1.919 Å)

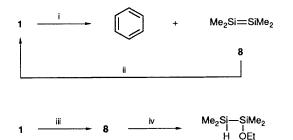
† Compound 1: air-sensitive colourless crystals; m.p. 43–44 °C; ¹H NMR (300 MHz, C₆D₆) δ 0.07 (s, 12H, SiMe₂), 2.79–2.84 (m, 2H, C=C-CH), 5.77–5.79 (m, 4H, CH=CH); ¹³C NMR (75.5 MHz, C₆D₆) δ –3.33, 34.98, 126.20; ²⁹Si NMR (59.6 MHz, C₆D₆) δ –25.0; UV (hexane) λ_{max} 226 nm (ϵ 3500); MS (70 eV, rel. int.) *m*/z 194 (M⁺ 2.7), 179 (1.7), 135 (6.2), 116 (100), 101 (34), 73 (73); high-resolution MS: calc. for C₁₀H₁₈Si₂: 194.0947; found 194.0943.

‡ Compound 6: ¹H NMR (300 MHz, C_6D_6) δ 0.08 (s, 3H), 0.11 (s, 3H), 0.12 (s, 3H), 0.14 (s, 3H), 0.17 (s, 3H), 0.18 (s, 6H), 0.28 (s, 3H), 1.35 (d, 1H, J 8 Hz), 1.88 (d, 1H, J 8 Hz), 2.01–2.04 (m, 1H), 2.82–2.87 (m, 1H), 5.81–5.88 (m, 2H), 5.98–6.03 (m, 1H), 6.36 (dd, 1H, J 14.5 and 3 Hz); ¹³C NMR (75.5 MHz, C_6D_6) δ – 5.07 (2C), -3.83, -3.70, -3.53, -3.21, -2.59, -2.24, 25.3, 26.5, 36.5, 41.4, 127.5 (2C), 131.2, 155.5; ²⁹Si NMR (59.6 MHz, C_6D_6) δ – 36.9, -23.0, -20.6, -16.5; MS (70 eV) *m*/z 336 (M⁺); high-resolution MS: calc. for $C_{16}H_{32}Si_4$: 336.1581; found: 336.1574.

§ The crystals for X-ray analysis were obtained from a methanol solution at 0 °C. A crystal of dimensions 0.2 × 0.4 × 0.5 mm was sealed in a capillary glass tube for data collection. A total of 2509 reflections within 20 = 128° were collected at -25°C on a Rigaku-Denki AFC 5R four-circle diffractometer with graphite-monochromated Cu-K\alpha radiation ($\lambda = 1.5418$ Å) by the 20 – ω scan. Crystal data: C₁₀H₁₈Si₂, M = 194.4, monoclinic, a = 11.990(1), b = 8.028(1), c = 13.555(1) Å, $\beta = 112.90(1)^\circ$, V = 1201.85(22) Å³, space group P2₄/c, Z = 4, $D_c = 1.075$ g cm⁻³. No absorption correction was applied. The final R factor was 0.0849 ($R_w = 0.0807$) for 1548 reflections with $F_o > 3\sigma$ (F_o). Atomic coordinates, bond lengths and angles, and thermal parameters have been deposited at the Cambridge Crystallographic Data Centre. See Notice to Authors, Issue No. 1.



Scheme 2 Reagents and conditions: i, Et₂O, 100 °C, 10000 bar, 12 h



Scheme 3 Reagents and conditions: i, $hv (\lambda = 254 \text{ nm})$, Ar, 10 K; ii, $hv (\lambda > 300 \text{ nm})$, Ar, 10 K; iii, $hv (\lambda = 254 \text{ nm})$, EPA, 77K; iv, EtOH

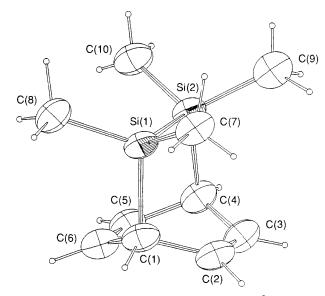


Fig. 1 ORTEP drawing of 1. Selected bond lengths (Å): Si(1)-Si(2)2.363(2), Si(1)-C(1) 1.919(7), C(1)-C(2) 1.505(9), C(2)-C(3)1.351(9), Si(1)-C(7) 1.872(7). Selected bond angles (°): C(1)-Si(1)-Si(2) 96.9(2), C(1)-C(2)-C(3) 118.3(7), C(2)-C(1)-C(6) 109.6(6). Dihedral angle (°): Si(1)-Si(2)-C(4)-C(1)/C(2)-C(3)-C(5)-C(6)90.1.

are significantly lengthened and the bond angles around the bridged Si atoms (C–Si–Si av. 96.3°) are highly contracted. These structural features suggest the high reactivity of **1**.

The base peak is found at m/z 116 in the mass spectrum of 1, and can be assigned to the cation radical of tetramethyldisilene

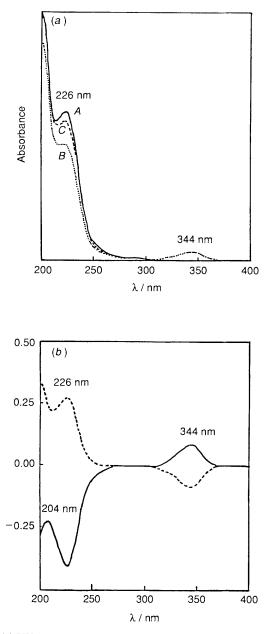


Fig. 2 (*a*) UV spectra of 1 in Ar matrix at 10 K: A: before irradiation (---); B: after 90 sec irradiation $(\lambda = 254 \text{ nm})$ (------); C: after additional irradiation $(\lambda > 300 \text{ nm})$ of the above sample for 30 sec (-----). (*b*) Differential spectra: B - A (-----); C - B (-----). 1: 226 nm; Me₂Si=SiMe₂ 8: 344 nm; benzene 204 nm.

formed by loss of benzene. The exact mass of the peak shows a composition of $C_4H_{12}Si_2$ consistent with the tetramethyldisilene (calc. 116.0478; found 116.0476). Thus, compound 1 could be a precursor of Me₂Si=SiMe₂. In fact, upon heating of 1 at 225 °C with anthracene in a sealed tube, a tetramethyldisilene adduct 4 was formed cleanly.

Of particular interest is the photochemical reaction of 1 to give tetramethyldisilene 8 and benzene. Argon-diluted 1,

deposited on a sapphire window cooled to 10 K,¶ was irradiated with 254 nm light, which resulted in a decrease of the UV absorption intensity at 226 nm of 1 with concurrent formation of a new band with a λ_{max} at 344 nm. The same absorption band was observed in 3-methylpentane (3-MP) or EPA (a 5:5:2 mixture of diethyl ether, iso-pentane and ethanol) matrix at 77 K. On annealing the EPA matrix, a product of addition of ethanol to 8 was formed. Accordingly, the band at 344 nm can be assigned to that of tetramethyldisilene 8.

Assignment of the UV absorption of tetramethyldisilene has been controversial until now. An absorption band near 350 nm was observed and assigned to tetramethyldisilene formed by dimerization of dimethylsilylene in a 3-MP or a 3-MP-isopentane matrix at 77 K;⁶ on the basis of laser flash photolysis experiments, this absorption was assigned to dimethylsilylene.⁷ Our experiment clearly shows that the absorption band at 344 nm is attributable to Me₂Si=SiMe₂.

Immediate disappearance of the band at 344 nm accompanied by simultaneous regeneration of the 226 nm band was observed by additional brief irradiation of the matrix of 8 with light of wavelength longer than 300 nm. This observation indicates that the disilene 8 reacts with benzene in the argon matrix at 10 K. It is likely that excitation of the disilene 8 results in π -bond breaking to form the diradical Me₂Si–SiMe₂ followed by the subsequent reaction with benzene in the matrix to regenerate 1.

Received, 16th October 1990; Com. 0/04655H

References

- 1 G. Raabe and J. Michl, J. Chem. Rev., 1985, **85**, 419; G. Raabe and J. Michl, in *The Chemistry of Organic Silicon Compounds*, part 2, eds. S. Patai and Z. Rappoport, Wiley, New York, 1989.
- D. N. Roark and G. J. D. Peddle, J. Am. Chem. Soc., 1972, 94, 5837; T. J. Barton and J. A. Kilgour, J. Am. Chem. Soc., 1976, 98, 7231; T. J. Barton and J. A. Kilgour, J. Am. Chem. Soc., 1976, 98, 7746; H. Sakurai, T. Kobayashi and Y. Nakadaira, J. Organomet. Chem., 1978, 162, C43; H. Sakurai, Y. Nakadaira and T. Kobayashi, J. Am. Chem. Soc., 1979, 101, 487; H. Sakurai, Y. Nakadaira and H. Sakaba, Organometallics, 1983, 2, 1484.
- 3 J. D. Rich, T. J. Drahnak, R. West and J. Michl, J. Organomet. Chem., 1981, 212, C1; Y. Nakadaira, T. Otsuka and H. Sakurai, Tetrahedron Lett., 1981, 22, 2417; S. Masamune, S. Murakami and H. Tobita, Organometallics, 1983, 2, 1464.
- 4 K. Sakamoto, K. Obata, H. Hirata, M. Nakajima and H. Sakurai, J. Am. Chem. Soc., 1989, 111, 7641.
- 5 A. Laporterie, M. Joanny, H. Iloughmane and J. Dubac, Nouv. J. Chim., 1983, 7, 225.
- 6 H. Vancik, G. Raabe, M. J. Michlczyk, R. West and J. Michl, J. Am. Chem. Soc., 1985, 107, 4097; A. Sekiguchi, K. Hagiwara and W. Ando, Chem. Lett., 1987, 209.
- 7 A. S. Nazran, J. A. Hawari, D. Griller, I. S. Alnaimi and W. P. Weber, J. Am. Chem. Soc., 1984, 106, 7267; J. A. Hawari and D. Griller, Organometallics, 1984, 3, 1123.

 \P A Displex refrigerator (Air Products Inc.) was used for matrix isolation. The matrix-isolated sample was prepared by gas-phase deposition onto a sapphire window cooled to 10 K. The resulting matrix was irradiated with a mercury arc lamp through the quartz window.